

**Point defects interaction with extended defects in the Si-SiO<sub>2</sub> system [Electronic resource]**

Kropman, Daniel; Kämer, T.; Abru, Uno; Ugaste, Ülo; Mellikov, Enn Proceedings IVC-16 : Venice, 2004 2004 / p. SS1-TuP394 [CD-ROM]

[https://www.researchgate.net/publication/243760197\\_Point\\_Defects\\_Interaction\\_with\\_Extended\\_Defects\\_and\\_Impurities\\_and\\_Its\\_Influence\\_on\\_the\\_Si-SiO\\_2\\_System\\_Properties](https://www.researchgate.net/publication/243760197_Point_Defects_Interaction_with_Extended_Defects_and_Impurities_and_Its_Influence_on_the_Si-SiO_2_System_Properties)